Docket No. 244521US-2 DIV

IN RE APPLICATION OF: Takashi KUROI ET AL.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

GAU:

SERIAL NO: NEW APPLICATION			EXAMINER:
FILED:	HEREWITH		
FOR:	SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF		
REQUEST FOR PRIORITY			
COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313			
SIR:			
Full benefit of the filing date of U.S. Application Serial Number 09/401,849, filed September 22, 1999, is claimed pursuant to the provisions of 35 U.S.C. §120.			
		J.S. Provisional Application(s) is Application No.	claimed pursuant to the provisions of 35 U.S.C. <u>Date Filed</u>
Applicants claim any right to priority from any earlier filed applications to which they may be entitled pursuant to the provisions of 35 U.S.C. §119, as noted below.			
In the matter of the above-identified application for patent, notice is hereby given that the applicants claim as priority:			
COUNTRY JAPAN		APPLICATION NUMBER 11-141271	MONTH/DAY/YEAR MAY 21, 1999
Certified copies of the corresponding Convention Application(s) are submitted herewith			
will be submitted prior to payment of the Final Fee			
were filed in prior application Serial No. 09/401,849 filed September 22, 1999.			
were submitted to the International Bureau in PCT Application Number Receipt of the certified copies by the International Bureau in a timely manner under PCT Rule 17.1(a) has been acknowledged as evidenced by the attached PCT/IB/304.			
☐ (A) Application Serial No.(s) were filed in prior application Serial No. filed ; and			
☐ (B) Application Serial No.(s)			
☐ are submitted herewith			
☐ will be submitted prior to payment of the Final Fee			
		R	espectfully Submitted,
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